

Fig. 1  
(Prior Art)

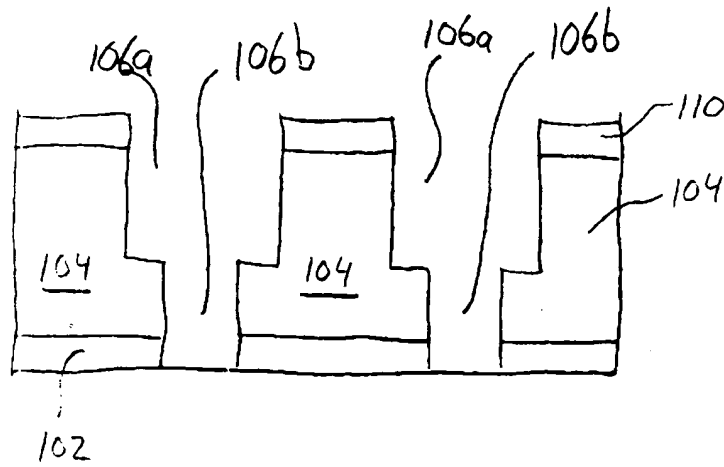


Fig. 2  
(Prior Art)

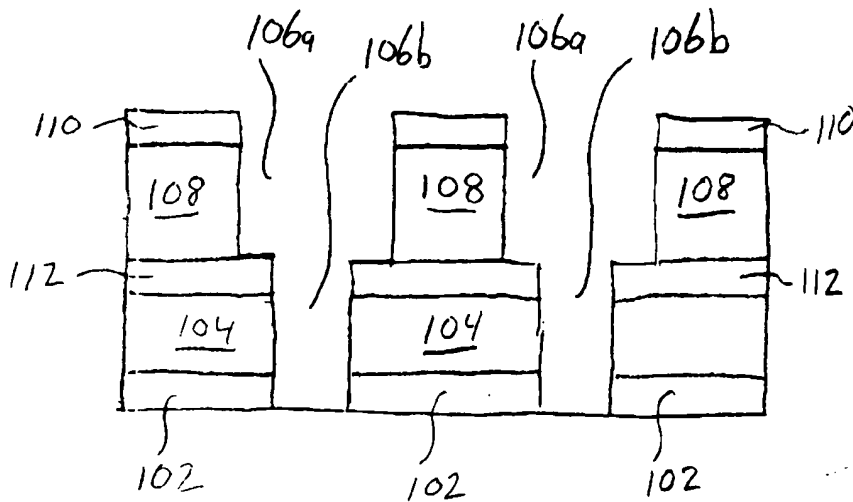
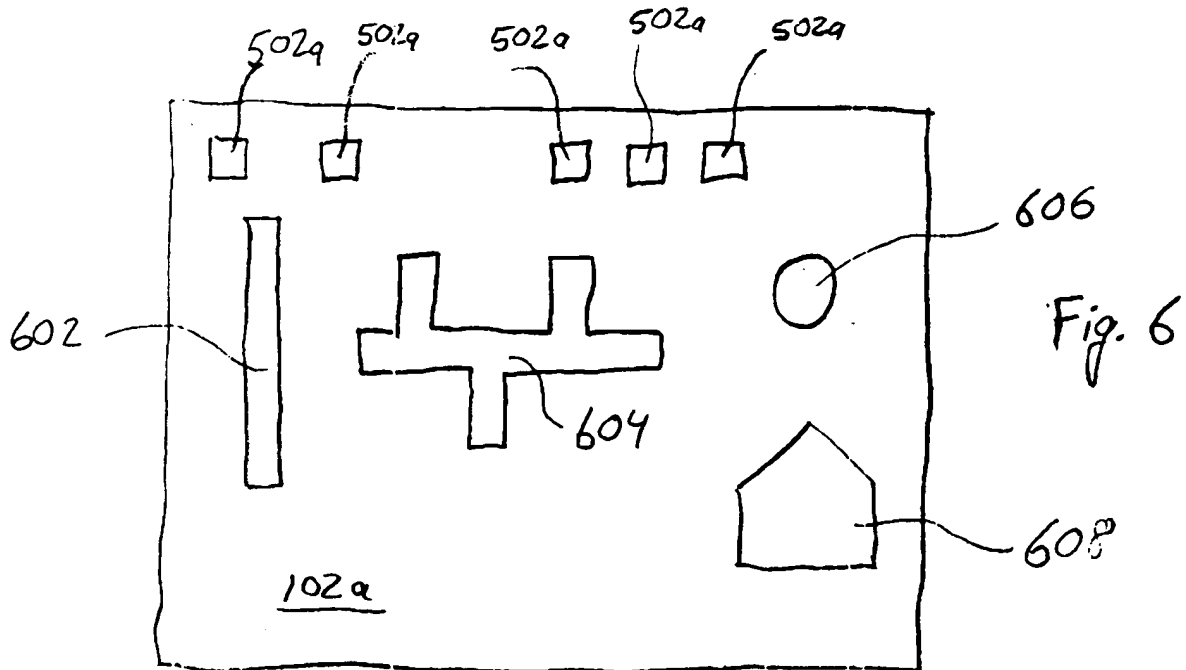
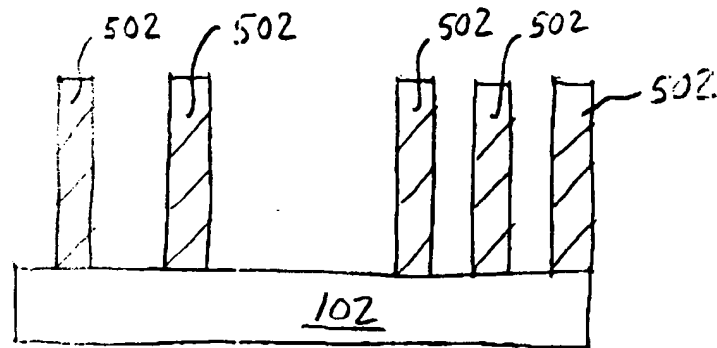
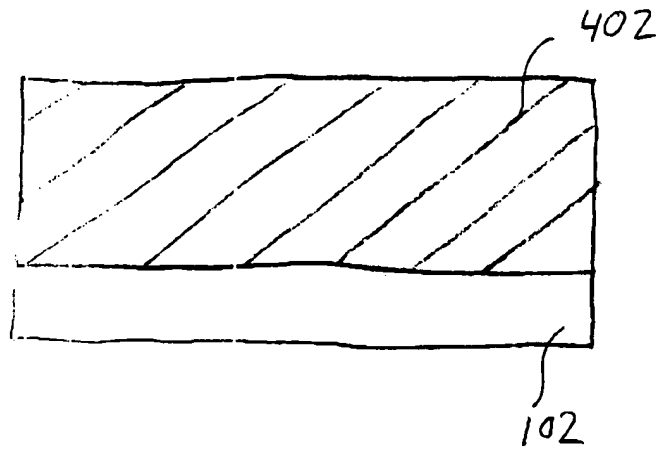


Fig. 3  
(Prior Art)

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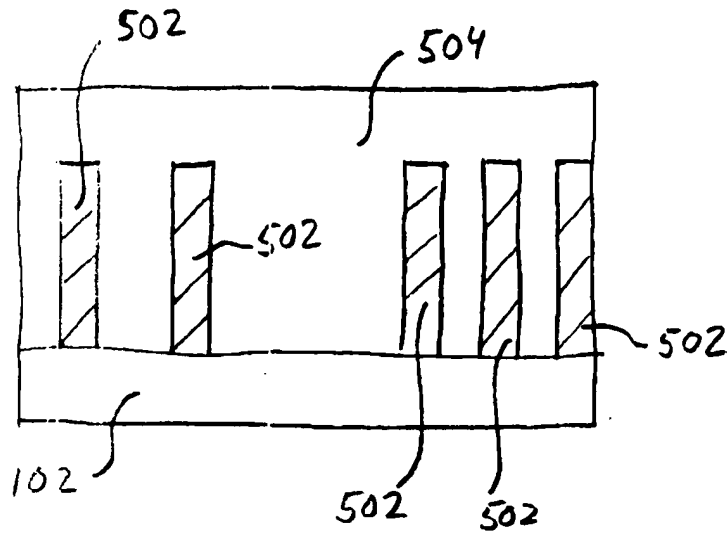


Fig. 7

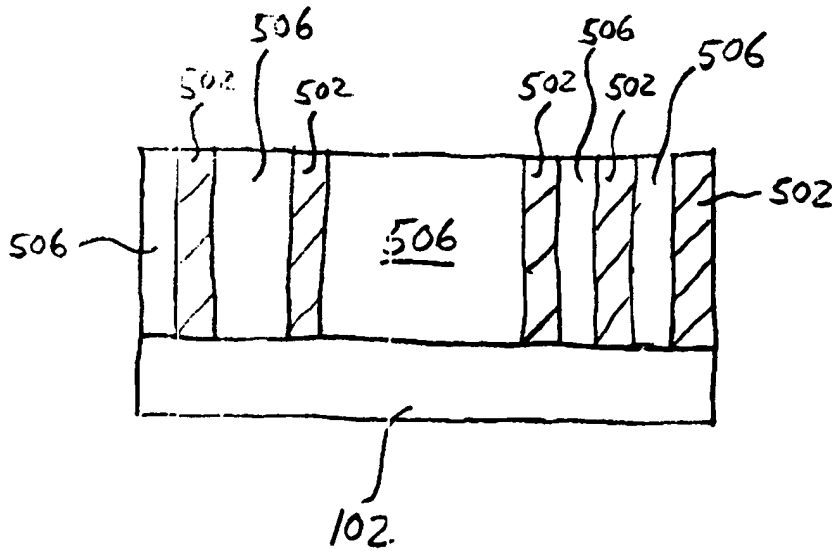
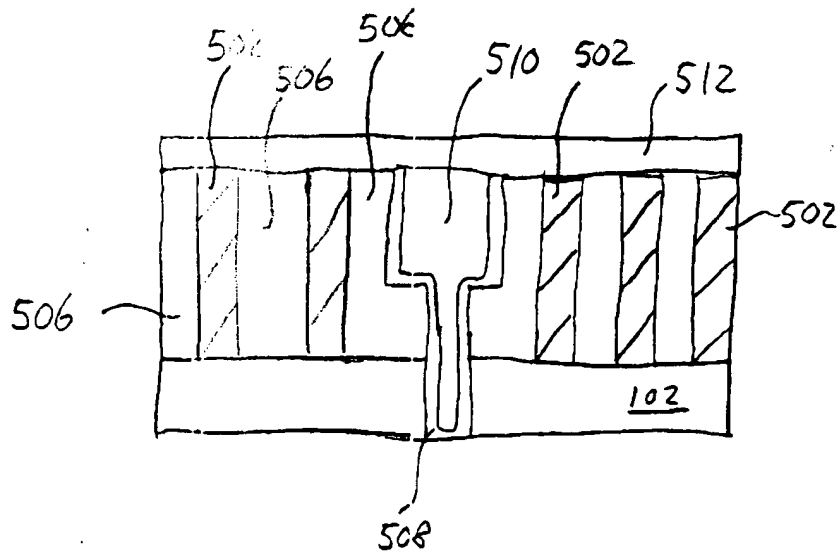
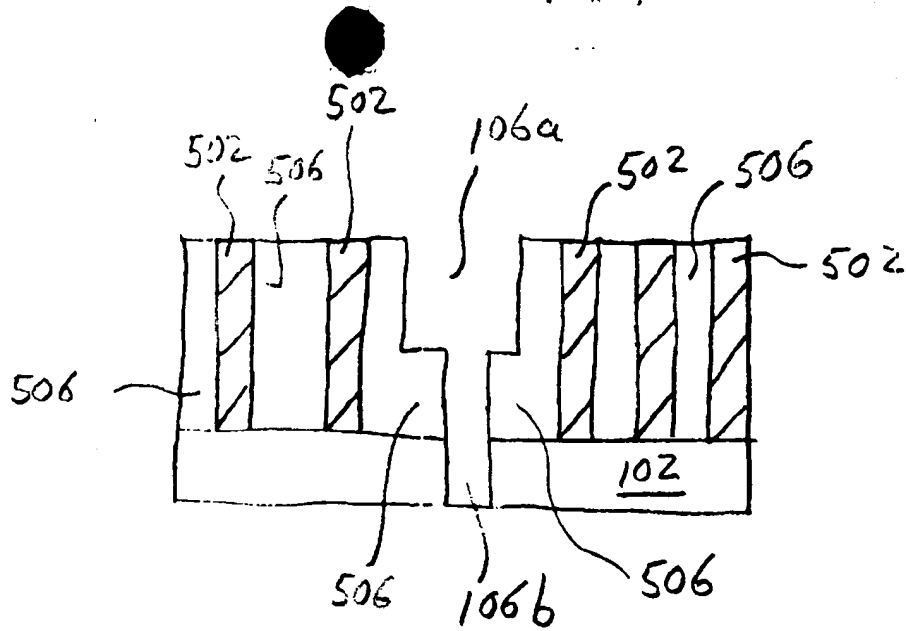


Fig. 8

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Form at least one vertically-oriented non-conductive reinforcing structure on a substrate

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Form a dielectric layer surrounding the reinforcing structure

Fig. 11

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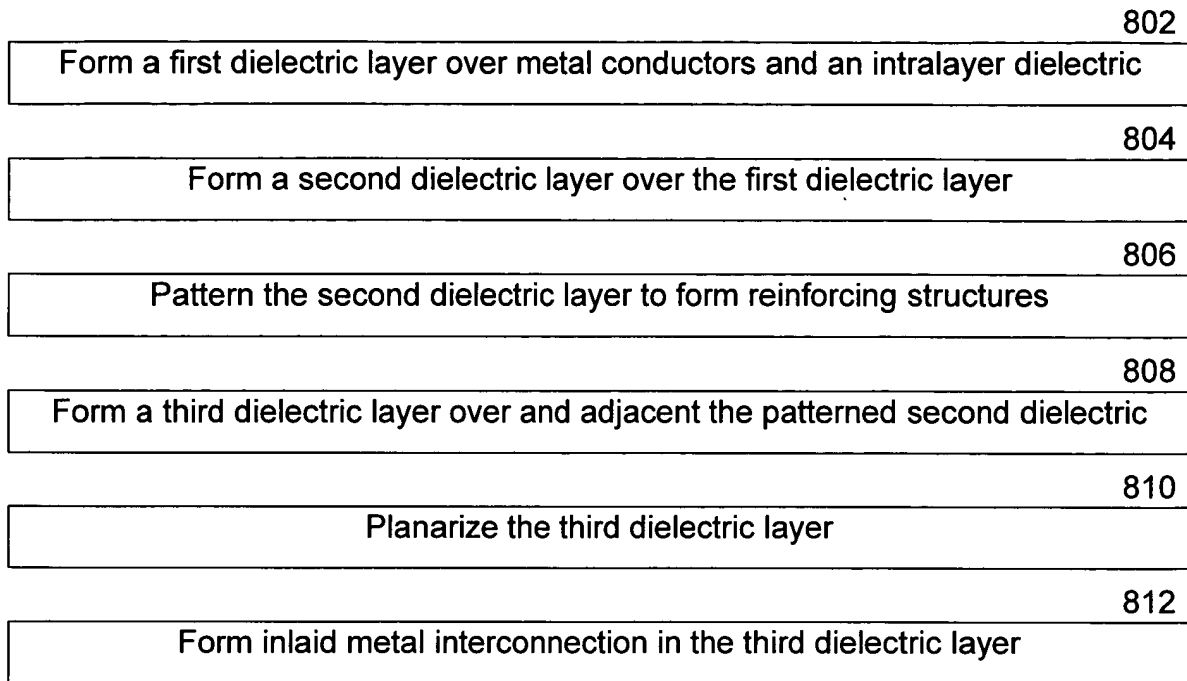


Fig. 12